Sub-Aperture Calibration for Adaptive Optics - overview Nicolò Azzaroli - minigrant

| Milestones Schedule | | | |
|----------------------------|----------|-----------|--|
| M.0 Kick Off | t0 | | |
| M.1 Simulator Ready | t0 + 3m | Completed | |
| M.2 Simulation completed | t0 + 6m | Completed | |
| M.3 Optical setup designed | t0 + 5m | Completed | |
| M.4 Optical test ready | t0 + 10m | Completed | |
| M.5 Test completed | t0 + 20m | On going | |
| M.6 Project completed | t0 + 24m | To Do | |

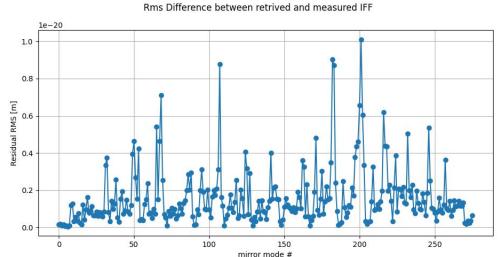
Scope

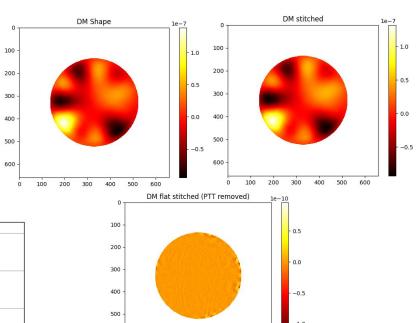
The aim of this project is to calibrate a DM by means of subaperture approach. The main goal is to reduce the optical test tower for future DM that are continuously increasing in size as well as the ground based telescopes

| Budget | | | |
|----------------|---------|---------------|--|
| Initial budget | 19.7 k€ | | |
| Expense | 9.0 k€ | optomechanics | |

Simulation Results

The simulator foresee the complete simulation of a deformable mirror with 88 actuators. The codes allow to map the whole DM surface by mean of sub-apertures step. Contribution of misalignment and measurement noise are taken into account. The stitching process is then optimized and tested on the simulated DM's influence functions with very high accuracy and low residual error.





200 300 400 500

Optical test setup - preliminar results

The optical test setup is already designed, procured and mounted in OAA laboratory and is composed as follow:

1) fast acquisition interferometer with 1:1 optical relay to relocate the instrument pupil position; 2) ALPAO DM88 is the deformable mirror under test 3) motorized tip-tilt mirror and linear stages to perform the scan for the stitching data acquisition.

Preliminar measurement shows an inconsistency between common regions of different subaperture positions. This suggest a non good alignment between the scan axis direction and the reconstructed image reference system (i.e. the Interferometer CCD). An optical target will be used to evaluate the offset angle between the laboratory and interferometer reference systems in order to fine tune the stitching algorithm.

